

Electronic Patent Application Fee Transmittal

Application Number:	10734479			
Filing Date:	12-Dec-2003			
Title of Invention:	Method for cleaning a deposition chamber and deposition apparatus for performing in situ cleaning			
First Named Inventor:	Eun-Taek Yim			
Filer:	Alexander Charles Johnson/Li mei Vermilya			
Attorney Docket Number:	2522-042			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Independent claims in excess of 3	1201	1	200	200
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				200